


<b>Search Notes</b>  	<b>Application/Control No.</b>  10528306	<b>Applicant(s)/Patent Under Reexamination</b>  THEVENOT, BENOIT
	<b>Examiner</b>  TAE W KIM	<b>Art Unit</b>  2887

SEARCHED			
Class	Subclass	Date	Examiner
235	492	2/2/08	KIM

SEARCH NOTES		
Search Notes	Date	Examiner
Text Search	10/1/06	KIM
EAST	10/1/06	KIM
Partial Class Search: 235/492, 156/272.8, 438/106,438/107,257/678	10/1/06	KIM
Consulted Jared Fureman @AU2876	10/27/06	KIM
Referenced Search Report for PCT/IB03/04011	3/21/07	KIM
Consulted Jared Fureman @AU2876	3/21/07	KIM
Consulted Steve Paik @AU2876	3/21/07	KIM
Search Updated	3/21/07	KIM
Consulted Steve Paik @AU2876	8/3/07	KIM
Search Updated	8/3/07	KIM
Search Updated	2/2/08	KIM

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
Same as Search		2/2/08	KIM